Physics of Computation

"Von Neumann" computing architecture





From "After Moore's Law," The Economist, March 2016

Brains vs. machines





Brain-like functions are more probabilistic in nature and use different data representations.

How to compute with nanoscale, lowpower, *stochastic* circuit components?



HI horizontal cells connected via gap junctions



HI horizontal cells labeled following injection of one HI cell (*) ×300 after Dacey, Lee, and Stafford, 1996 Hyperpolarization of photoreceptor results in hyperpolarization of horizontal cells



Hyperpolarization of horizontal cell results in depolarization of photoreceptors



Hyperpolarization of horizontal cell spreads to other horizontal cells via gap junctions



Lateral inhibition



Lateral inhibition



Rod bipolar cells sum thresholded outputs of rods (not linear) (Sampath, Field, Rieke 2002-2004)



The processes of drift and diffusion are the stuff of which all information processing devices—both neural and semiconductor—are made.

-Carver Mead (1989)



Lessons from the Early Days of Semiconductors - Carver Mead - 4/24/2019

https://www.youtube.com/watch?v=qhJaq3k16Dc&feature=youtu.be

RADIO COMMUNICATIONS

1745 Leyden Jar 1769 Franklin – Electricity 1799 Volta – Battery 1831 Faraday - Induction 1836 Ruhmkorff – Induction Coil 1853 Kelvin – Analysis of Discharge 1865 Maxwell - E&M Thy 1880 Edison – Thermionic Diode 1888 Hertz – Electromagnetic Waves 1895 Marconi – Radio Comms 1902 Poulson – CW Arc Transmitter 1906 Pickard – Silicon Detector 1907 de Forest – Thermionic Triode 1913 Langmuir – High Vacuum Triode 1916 de Forest - Com. Broadcast 1917 – 1919 Radio Ban WWI 1920 Com. Broadcast – KDKA 1922 Over 500 AM Com. Stations 1927 Nationwide Broadcast – NBC 1927 Farnsworth – First Television 1950s TV ubiquitous 1973 Cooper - Cell Phone 1981 1G Cell Networks

ELECTRONS IN VACUUM

1745 Leyden Jar 1769 Franklin – Electricity 1799 Volta – Battery 1831 Faraday – Induction 1836 Callen, Ruhmkorff – Induction Coil 1853 William Thomson – Spark Analysis 1858 Feddersen – Oscillating Spark 1880 Edison – Thermionic Emission 1890 Fleming – Thermionic Diode 1898 Elster & Geitel – Electron e/m 1899 J.J. Thomson – Electron e & m 1907 de Forest – Thermionic Triode 1913 Langmuir – High-vacuum Triode 1922 Lilienfeld – Field Emission 1960s Ken Shoulders – Micro-triode 1960s GE - TIMM



SOLID-STATE DEVICES

1799 Volta – Battery 1833 Faraday – Semiconductors 1877 Braun - Contact Rectification 1879 Hall – Hall Effect 1906 Pickard – Silicon Detector 1907 – 1911 Baedeker – Semiconductor Doping 1922 Grondahl – CuO Rectifier 1923 Lossev – Oscillating Crystal 1925 Lilienfeld – MESFET 1928 Lilienfeld – MOSFET 1928 – 1931 Bloch et. al. – Band Picture 1942 Schottky – Barrier Thy & Expt 1948 Bardeen & Brattain – Point-Contact Transistor 1948 Shockley – Junction Transistor 1952 Pankove – Alloy Germanium Transistor 1954 Pacific Semiconductors Inc. 1955 Derik & Frosch – Oxide Masking 1955 Shockley Labs 1956 Tannenbaum et. al. - Diffused Si Transistor 1957 Fairchild 1959 Kilby – All-Semiconductor Circuit 1959 Hoerni – Planar Process 1959 Noyce – Integrated Circuit 1960 Kahng & Atalla – MOSFET working 1963 Wanlass – CMOS 1965 Mead – MESFET working 1965 Dennard – DRAM altach

1965 Moore's Law

Nernst potential (aka 'reversal potential')

$$V = -\frac{kT}{q} \log \frac{N_{\text{in}}}{N_{\text{ex}}} \quad \text{or} \quad N_{\text{in}} = N_{\text{ex}} e^{-\frac{q}{kT}V}$$

Current-voltage relation of voltage-gated channels

$$\frac{\theta}{1-\theta} = e^{-E_0/kT} e^{qnV/kT} \qquad \Theta = \text{fraction of channels open}$$

Current-voltage relation of MOS transistor

$$I = I_0 e^{-\frac{q V_{gs}}{kT}} (1 - e^{\frac{q V_{ds}}{kT}}) \qquad \begin{array}{l} V_{gs} = \text{gate-source voltage} \\ V_{ds} = \text{drain-source voltage} \end{array}$$

All of these things are related by the same fundamental physical law...

Its the Boltzmann distribution!

Example: atmospheric pressure vs. elevation

$$v_{\text{drift}} = \frac{wt_f}{2m} = v_{\text{diff}} = -\frac{1}{2N} \frac{dN}{dh} kT \frac{t_f}{m}$$
$$\frac{1}{N} \frac{dN}{dh} kT = -w$$
$$kT \ln \frac{N}{N_0} = -wh$$
$$\text{or, for election}$$
$$N = N_0 e^{-\frac{wh}{kT}}$$

or, for charge in an electric field:

$$N = N_0 e^{-\frac{q}{kT}V}$$

Voltage-gated channels







$$\frac{N_{\rm o}}{N_{\rm c}} = e^{-E_t/(kT)}$$

$$E_{\rm t} = E_0 - Vnq$$

 E_t = transition energy E_0 = transition energy at V=0

$$\frac{\theta}{1-\theta} = e^{-E_0/(kT)} e^{qnV/(kT)}$$

$$\theta = N_{\rm o}/N$$

MOS transistor



FIGURE 3.4 Cross-section (a) and energy diagram (b) of an *n*-channel transistor. In a typical 1988 process, the gate-oxide thickness is approximately 400 angstroms (0.04 micron), and the minimum channel length *I* is approximately 1.5 microns. When the circuit is in operation, the drain is biased positively; hence, the barrier for electrons is greater at the drain than at the source. Applying a positive voltage at the gate lowers the electron barrier at both source and drain, allowing electrons to diffuse from source to drain.

$$I = I_0 e^{-\frac{q V_{gs}}{kT}} (1 - e^{\frac{q V_{ds}}{kT}}) \qquad V_{gs} = \text{gate-source voltage} \\ V_{ds} = \text{drain-source voltage}$$



The exponential current-voltage relation in the nerve is a result of the same physical laws responsible for the exponential transistor characteristic. There is an energy barrier between a state in which current can flow and one in which current cannot flow. The height of that barrier is dependent on a control voltage. The Boltzmann distribution determines the fraction of the total population that is in the conducting state. In the transistor, the electrons in the channel form the population in question, and these same electrons carry the current. In the nerve membrane, the channels form the population in question, and ions in the channels carry the current. In both cases, the number of individual charges in transit is exponential in the control voltage, and the transport of these charges results in a current that varies exponentially with the control voltage.

Transconductance amplifier

Differential pair



Differential pair



Transconductance amplifier





Silicon retina

Analog VLSI retina (Mead & Mahowald, 1989)



Analog VLSI (or neuromorphic computing) exploits intrinsic transistor physics and laws of electronics (Kirchhoff's law, Ohm's law) to do computation



3D RRAM crossbar array





Solving matrix equations in one step with cross-point resistive arrays

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